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INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary)

Applicant(s)

Masahiko Ishida et al.

Filing Date

March 22, 2006

Group Art Unit

unknown

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

U.S. PATENT APPLICATION PUBLICATIONS

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FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
/M.H./		2003-238123	08.27.2003	NEC CORP. JPX	Int. Cl		✓	
/M.H./		2003-017508	17.01.2003	NEC CORP. JPX	Int. Cl		✓	

OTHER DOCUMENTS

(Including Author, Title, Date, Pertinent Pages, Etc.)

/M.H./		J. Fujita et al. Graphitization of FE-doped amorphous carbon pillars grown by focused-ion-beam-induced chemical-vapor deposition, Journal of Vacuum Science & Technology B, second series, volume 20, number 6, 11/2002; pages 2686-2689
/M.H./		Yoshikazu Homma et al. Growth of suspended carbon nanotube networks on 100-nm-scale silicon pillars; Applied Physics Letters, volume 81, number 12; 09.16.2002; pages 2261-2263

EXAMINER /Michelle Hou/

DATE CONSIDERED 12/23/2008

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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All references considered except those lined through M.H.

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